PTO/SB/08B (07-05)

Approved for use through 07/31/2008. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

	te for form 1449/PTO			ce required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known			
Subsul	28 IO IOIII 1443/F10			Application Number	10/632,740		
INF	ORMATION	N DIS	CLOSURE	Filing Date	08/01/2003		
STA	ATEMENT I	BY A	PPLICANT	First Named Inventor	Bellaiche, L.		
				Art Unit	1755		
(Use as many sheets as necessary)			lecessary)	Examiner Name	Koslow, C.		
Sheet	1	of	1	Attorney Docket Number	8793-52026		

Examiner	Cite	NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of		
the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-iss number(s), publisher, city and/or country where published.				
CMK	CMK A HITOSHI, T., et al., Formation of artificial BaTiO3/SrTiO3 superlattices using pulsed laser deposition and their dielectric properties, Appl. Phys. Lett. 65 (15),			
		10 October 1994, pp. 1970-1972.		
CMK	В	ZHAO, T., et al., Enhancement of second-harmonic generation in BaTiO3/ SrTiO3 superlattices, Physical Review B 60 (3), 15 July 1999, pp. 1697-1700.		
		CHRISTEN, HM., et al., The growth and properties of epitaxial KNbO3 thin films and KNbO3/KTaO3 superlattices, Appl. Phys. Lett. 68 (11), 11 March 1996, pp. 1488-90.		

		·		

Examiner	/C. Melissa Koslow/	Date Considered	06/12/2006
Signature	•	Considered	00/12/2000

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

1 This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.